


# TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

Title of Invention	REMOVAL OF MEMS SACRIFICIAL LAYERS USING SUPERCRITICAL FLUID/CHEMICAL FORMULATIONS	
Application Number : Date : First Named Applicant: Confirmation Number: Attorney Docket Number:	10/782355 2004-02-19 Korzenski Michael B. 4186 020732-103.686CIP	
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		Sign. Capacity Attorney

Documents being submitted:		Files
us-ids		ATMI103-usidst.xml us-ids.dtd us-ids.xsl
us-fee-sheet		ATMI103-usfees.xml us-fee-sheet.xsl us-fee-sheet.dtd
Comments		